| Ref # | Hits | Search Query | DBs | Default Operat or | Plural s | Time Stamp |
|----------|------|---|-------------------------------------|-------------------------|-------------|---------------------|
| L1 | 1 | (micromechanical near switch\$2) and (movable near mass\$2) and (first near spring near element\$1) and (contact near element\$1) and (second near spring near element\$1) and (second near spring near element\$1) and (displacement).clm. | US-PGPU B; USPAT; EPO; JPO | OR | ON | 2006/02/15 17:30 |